



Docket No.: OMY-0034
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masatoshi SHIRAI SHI et al.

Application No.: 10/735,926

Confirmation No.: 4251

Filed: December 16, 2003

Art Unit: 1756

For: SUBSTRATE PROCESSING METHOD AND
SUBSTRATE PROCESSING APPARATUS

Examiner: D. Chacko Davis

RESPONSE TO RESTRICTION REQUIREMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

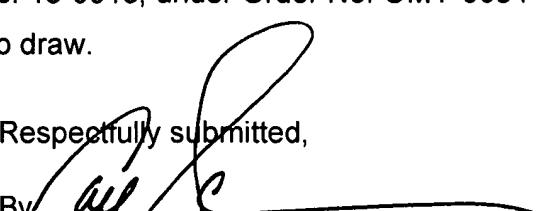
In response to the Restriction Requirement dated November 30, 2006, Applicant hereby provisionally elects, without traverse, Group IV, claim 22-25, for continued examination.

Please note that Applicant reserves the right to file divisional applications covering the subject matter of the non-elected claims.

Applicant believes no fee is due with this response. However, if a fee is due, please charge our Deposit Account No. 18-0013, under Order No. OMY-0034 from which the undersigned is authorized to draw.

Dated: January 26, 2007

Respectfully submitted,

By 
Carl Schaukowitch

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